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| APPLICATION NO. | FILING DATE | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO. | CONFIRMATION NO |
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| 10/041,621 | 01/10/2002 | Young-Sin Park | 030681-346 | 5259 |
| · - | 11/13/2004 | | EXAMINER | |
| BURNS DOANE SWECKER & MATHIS L L P POST OFFICE BOX 1404 | | | CREPEAU, JONATHAN | |
| | A, VA 22313-1404 | | ART UNIT | PAPER NUMBER |
| | | | 1746 | |

DATE MAILED: 11/15/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

| | | Application No. | Applicant(s) |
|--|--|--|---|
| Office Action Summary | | 10/041,621 | PARK ET AL. |
| | | Examiner | Art Unit |
| | TI. 11411 1100 0 1 | Jonathan S. Crepeau | 1746 |
| Period f | The MAILING DATE of this communication app or Reply | pears on the cover sheet with the c | correspondence address |
| - Extended and the control of the co | MORTENED STATUTORY PERIOD FOR REPL' MAILING DATE OF THIS COMMUNICATION. Pensions of time may be available under the provisions of 37 CFR 1.13 of SIX (6) MONTHS from the mailing date of this communication. The period for reply specified above is less than thirty (30) days, a reply of period for reply is specified above, the maximum statutory period of the reply within the set or extended period for reply will, by statute, reply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b). | 36(a). In no event, however, may a reply be tir y within the statutory minimum of thirty (30) day vill apply and will expire SIX (6) MONTHS from | nely filed s will be considered timely. the mailing date of this communication. |
| Status | | | |
| 1)[| Responsive to communication(s) filed on 20 Au | ugust 2004 | |
| | | action is non-final. | |
| | Since this application is in condition for allowar | ICE except for formal matters, and | econution on to the man day to |
| , | closed in accordance with the practice under E | x parte Quavle 1935 € □ 14 4 | SOC 212 |
| Disposit | ion of Claims | x parte Quayre, 1933 C.D. 11, 45 | 03 O.G. 213. |
| | | | |
| 7/63 | Claim(s) <u>1-13</u> is/are pending in the application. | un finanza a di Maria | |
| 5)□ | 4a) Of the above claim(s) is/are withdraw Claim(s) is/are allowed. | vn from consideration. | |
| | Claim(s) <u>1-13</u> is/are rejected. | | |
| | | | |
| | Claim(s) is/are objected to. | | |
| | Claim(s) are subject to restriction and/or | election requirement. | |
| | on Papers | | |
| | The specification is objected to by the Examiner | | |
| 10) | The drawing(s) filed on is/are: a)☐ acce | pted or b) objected to by the E | xaminer. |
| | Applicant may not request that any objection to the d | rawing(s) be held in abeyance. See | 37 CFR 1.85(a). |
| | Replacement drawing sheet(s) including the correction | on is required if the drawing(s) is obje | ected to. See 37 CFR 1 121(d) |
| 11)[| The oath or declaration is objected to by the Exa | aminer. Note the attached Office | Action or form PTO-152 |
| | nder 35 U.S.C. § 119 | | 70 102. |
| 12) 🗌 / | Acknowledgment is made of a claim for foreign p ☐ All b) ☐ Some * c) ☐ None of: | oriority under 35 U.S.C. § 119(a)- | (d) or (f). |
| | 1. Certified copies of the priority documents | have been received | |
| | 2. Certified copies of the priority documents | | n No |
| | 3. Copies of the certified copies of the priorit | v documents have been received | II NO |
| | application from the International Bureau | (PCT Pule 17 2(a)) | in this National Stage |
| * S | ee the attached detailed Office action for a list of | f the certified copies not received | |
| | and the second of the second o | the certified copies flot received | · |
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| Attachment(□ Notice | s) of References Cited (PTO-892) | , — | |
| 2) 🔲 Notice | of Draftsperson's Patent Drawing Review (PTO-948) | 4) 🔲 Interview Summary (F Paper No(s)/Mail Date | PTO-413) |
| 3) 📙 Inform | ation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) | 5) 🖳 Notice of Informal Pat | ent Application (PTO-152) |
| | No(s)/Mail Date | 6) | . , |
| Patent and Tra TOL-326 (Re | (4.04) | on Summary Part | of Paper No /Mail Date 20041110 |

Art Unit: 1746

DETAILED ACTION

Response to Amendment

1. This Office action addresses claims 1-13. The translation of the priority document is sufficient to remove JP 2001-256967 as prior art. However, the claims are newly rejected under 35 USC §103 herein, as necessitated by amendment. Accordingly, this action is made final.

Claim Rejections - 35 USC § 103

2. Claims 1, 11, and 13 are rejected under 35 U.S.C. 103(a) as being unpatentable over JP 11-86854 in view of Kanematsu et al (U.S. Patent 6,602,354).

Regarding claim 1, JP '854 teaches an anode material comprising an intermetallic material comprising a lithium-storing phase and a non-lithium storing phase (see abstract). The lithium storing phase is preferably Al, Si, Sn, or Pb (see paragraph 11 of the machine translation). The non-lithium storing phase is preferably Cr, Fe, Co, Ni, or Cu (see paragraph 16). These disclosures are considered to be anticipatory of an Ni-Sn intermetallic material. Further, the thin film anode comprises a current collector (see paragraph 20). Regarding claim 11, the anode is used in a lithium ion battery (see paragraph 11).

JP '854 does not expressly teach that the intermetallic compound is heat-treated in the range of 300-500 degrees C, as recited in claim 1.

Kanematsu et al. is directed to a method for producing a tin-nickel alloy film. In the method, the materials are heated in a range of about 232-400 degrees C (see col. 2, lines 43-51).

Art Unit: 1746

Therefore, the invention as a whole would have been obvious to one of ordinary skill in the art at the time the invention was made because the artisan would be motivated to apply the heat treatment of Kanematsu et al. to the intermetallic compound of JP '854. In column 2, line 3, Kanematsu et al. teach the following:

Therefore, even though the non-equilibrium NiSn phase is generated, it is shifted to another stable NiSn phase in the heat-diffusion process of the present invention. As a result, since the thus obtained tin-nickel alloy film does not have the non-equilibrium NiSn phase, different from the above electroplated tin-nickel alloy film, it can maintain its original properties in use, and the original functions given to the tin-nickel alloy film can be maintained for a long time.

As such, the artisan would be sufficiently motivated to apply the heat treatment of Kanematsu et al. to the intermetallic compound of JP '854.

3. Claims 1, 2, and 9-13 are rejected under 35 U.S.C. 103(a) as being unpatentable over Bito et al (U.S. Patent 6,265,111) in view of Kanematsu et al.

Regarding claim 1, Bito teaches a thin film anode comprising a current collector and an anode material comprising an Sn-Ni intermetallic compound thereon (see abstract; col. 3, line 32). Regarding claims 2, 10, and 12, the intermetallic compound can be Ni₃Sn₄ (see Table 1, line 8). Regarding claim 11, the anode is used in a lithium ion battery (see abstract). Regarding claim 9, the anode material may be made by a mechanical alloying method and an ion-beam assisted deposition method (see col. 6, line 43 et seq.).

Art Unit: 1746

Although Bito teaches that some particles having surface coatings are heat treated (see Example 3 and Table 4), Bito does not expressly teach that the Ni₃Sn₄ intermetallic compound is heat-treated in the range of 300-500 degrees C, as recited in claim 1.

Kanematsu et al. is directed to a method for producing a tin-nickel alloy film. In the method, the materials are heated in a range of about 232-400 degrees C (see col. 2, lines 43-51).

Therefore, the invention as a whole would have been obvious to one of ordinary skill in the art at the time the invention was made because the artisan would be motivated to apply the heat treatment of Kanematsu et al. to the intermetallic compound of Bito. In column 2, line 3, Kanematsu et al. teach the following:

Therefore, even though the non-equilibrium NiSn phase is generated, it is shifted to another stable NiSn phase in the heat-diffusion process of the present invention. As a result, since the thus obtained tin-nickel alloy film does not have the non-equilibrium NiSn phase, different from the above electroplated tin-nickel alloy film, it can maintain its original properties in use, and the original functions given to the tin-nickel alloy film can be maintained for a long time.

As such, the artisan would be sufficiently motivated to apply the heat treatment of Kanematsu et al. to the intermetallic compound of Bito.

4. Claims 3-8 are rejected under 35 U.S.C. 103(a) as being unpatentable over Bito et al. in view of Kanematsu et al. as applied to claims 1, 2, and 9-13 above, and further in view of JP 4-308081.

Bito further teaches that the manufacturing methods include ion beam "sputtering" and vacuum vapor deposition (col. 6, line 46). However, Bito et al. do not expressly teach that the

Art Unit: 1746

sputtering is mosaic sputtering (claim 3), co-sputtering (claim 5), or single-target sputtering (claim 7).

JP 4-308081 is directed to a sputtering target. As disclosed in the Derwent abstract, the target is a "mosaic" target that comprises pieces of two different compositions assembled on a single base plate. The compositions are elemental metals.

Therefore, the invention as a whole would have been obvious to one of ordinary skill in the art at the time the invention was made because the artisan would be motivated to use the sputtering target of JP '081 to form the anode material of Bito et al. In the JPO abstract, the reference teaches that the purpose of the invention is "to reduce the fraction defective of products by specifying the percentage of single crystals and/or macro-grains of the constituents of a target." Further, the abstract teaches that "the productivity of the target can be improved." As such, the artisan would be motivated to use the sputtering target of JP '081 (modified to include Sn and Ni) to form the anode material of Bito et al. The target of JP '081 is considered to render obvious all the limitations of the instant claims, i.e., it can be used in mosaic sputtering, cosputtering, and single target sputtering (since the target as a whole can be considered to be a "single" target).

Response to Arguments

5. Applicant's arguments filed August 20, 2004 have been fully considered but they are not persuasive. Applicants assert that JP '854 discloses "laundry lists" of elements suitable for use in the intermetallic compound, and as such, JP '854 does not anticipate or render obvious the

Art Unit: 1746

claimed NiSn compound. However, as noted in the rejection above, the preferred elements are Al, Si, Sn, or Pb (first element), and Cr, Fe, Co, Ni, or Cu (second element). The fact that these elements are disclosed as being preferred would provide sufficient guidance for an artisan to use them in various combinations. Further, the lists of preferred elements contain relatively few (i.e, four or five) members and therefore are not believed to constitute "laundry lists." It is noted that the reference teaches an NiSi material in paragraph 12. Since Al, Si, Sn, or Pb are all disclosed as being preferred first elements, the artisan may reasonably conclude that Si is functionally equivalent to Sn, Al, and Pb. As such, this disclosure is considered to fairly suggest an NiSn compound. If Applicant wishes to submit evidence showing that Sn performs better than Al, Si, or Pb in an intermetallic compound with Ni, such evidence would be considered by the Examiner.

Conclusion

6. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, THIS ACTION IS MADE FINAL. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37

Art Unit: 1746

CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jonathan Crepeau whose telephone number is (571) 272-1299. The examiner can normally be reached Monday-Friday from 9:30 AM - 6:00 PM EST.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael Barr, can be reached at (571) 272-1414. The phone number for the organization where this application or proceeding is assigned is (571) 272-1700. Documents may be faxed to the central fax server at (703) 872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Monathan Crepeau Primary Examiner Art Unit 1746 November 10, 2004